

Title (en)  
Corrosion resistant polycrystalline abrasive compacts

Title (de)  
Korrosionsbeständige polykristalline Schleifpresskörper

Title (fr)  
Korrosionsbeständige polykristalline Schleifpresskörpern

Publication  
**EP 1033414 A3 20020918 (EN)**

Application  
**EP 00301474 A 20000224**

Priority  
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Abstract (en)  
[origin: EP1033414A2] A supported abrasive particle compact is composed of a cobalt-cemented carbide support integrally bonded to an abrasive particle layer of self-bonded diamond particles or CBN particles. The cobalt content in said supported compact is provided in form of a nickel-cobalt alloy wherein the amount of nickel is such that the cobalt is present in the face center cubic (FCC) or e phase. The inventive cutters can be made by infiltration of Ni metal into cemented WC substrate and/or the polycrystalline layer bonded thereto. Bonding includes high pressure/high temperature (HP/HT) formation of the supported polycrystalline compact and the brazing of the polycrystalline compact to the support. <IMAGE>

IPC 1-7  
**C22C 29/06**; **C22C 29/08**; **C22C 29/10**; **B22F 7/06**

IPC 8 full level  
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**B22F 7/06** (2013.01 - EP KR); **B24D 3/34** (2013.01 - EP KR); **B24D 3/342** (2013.01 - EP KR); **B22F 2005/001** (2013.01 - EP KR)

Citation (search report)  
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